## **SEM** - resolution

Topography imaging (secondary electrons):

Resolution = electron beam diameter = d

$$d = \sqrt{\frac{i}{E}} \frac{a}{r}$$

i = beam current (probe current, spot size):  $10^{-12} - 10^{-6}$  A

E= acceleration voltage: 5-20kV

a= working distance (distance between objective lens and specimen); 5-50mm

## SEM – depth of field

Depth of field = maximum difference in height where an image of a specimen is in focus =  $\mathbf{D}$ 

$$D = \left(\frac{\delta}{M} - d\right) \frac{a}{r}$$

 $\delta$  = resolution of the eye = 0.1mm

a = working distance: 5-50mm

r = aperture radius (typical 3-4 values)